

Atomic layer deposition of alumina on g-Al₂O₃ nanofibres

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Oxygen barrier properties of Al₂O₃- and TiO₂-coated LDPE films

Lange, Sven; Arroval, Tõnis; Saar, Rando; Kink, Ilmar; Aarik, Jaan; **Krumme, Andres** Polymer-plastics technology and engineering 2015 / p. 301-304 : ill <http://dx.doi.org/10.1080/03602559.2014.977426>